ALABAMA DEPARTMENT OF ENVIRONMENTAL MANAGEMENT Air Division

Instructions for Completion of Form ADEM 438

- Item 1: Self explanatory.
- Item 2: Check the appropriate box for the pollutant or parameter listed which will be monitored by this Continuous Emission Monitoring System. If the pollutant or parameter is not listed, check the box named "other" and explain what pollutant or parameter is being monitored.
- Item 3: On the appropriate lines: list the name of the manufacturer (ex.: TECO, Rosemount, etc.), list the model number of the CEMS (ex.: RM 41, 10S, etc.), list the serial number which is stamped on the monitor.
- Item 4: Follow the instructions listed for number 3.
- Item 5: On the appropriate lines name the emission source that is to be monitored (ex.: #1 recovery boiler, #2 lime kiln, etc.). After the source name, indicate the location from where the effluent sample is extracted (ex.: stack, duct, etc.).
- Item 6: Give a short description of the calibration method (ex. : daily calibration with a zero gas and a midrange gas), then estimate how much down time will occur because of calibrations, maintenance, repairs, etc.
- Item 7: Self explanatory.
- Item 8: Check the appropriate box or boxes for which this CEMS applies.
- Item 9: Indicate the range that the monitor will be set at for this application (ex.: 0 to 500 ppm).
- Item 10: Indicate which performance protocol will be used in certifying this monitor (ex.: performance specification 2).
- Item 11: Indicate the type of monitor.
- Item 12: If the monitor is dilution extractive, indicate the ratio of dilution air used (ex. : 250 parts dry air to 1 part effluent).
- Item 13: Indicate whether or not the effluent is conditioned before it is measured by the monitor. If yes, indicate the type of conditioning system that will be used.
- Item 14: Self explanatory.

PERMIT APPLICATION FOR CONTINUOUS EMISSION MONITORING SYSTEMS (CEMS)

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L		 Do	not	writ	e in	this	sp	ace	

List	t pollutant or parameter the cor	ntinuous emission monitoring system is measuring:
	Sulfur dioxide	☐ Carbon monoxide
	Nitrogen oxides	☐ Particulates
	PM10	☐ Exhaust temperature
] Oxygen	☐ Hydrogen chloride
	Pressure	☐ Opacity
	Carbon dioxide	☐Temperature
		☐ Exhaust gas
		☐ Primary Chamber
		☐ Secondary chamber
	Total reduced sulfides	☐ Flow rate
	Hydrogen sulfide	□VOCs
	Other (explain):	
CEI	MS Manufacturer's information:	
Na	ame of manufacturer:	
Mo	odel number:	
Se	erial number:	
Dat	a acquisition system to be used	d (data logger, strip chart, etc.):
Na	ame of manufacturer:	
Se	erial number:	
	:k	nitored and the location of the specific CEM:

6.	Briefly describe the calibration and operational procedures to be used in operating the CEM: (indicate estimate of time lost in calibrating, maintaining, repairing, etc.)							
7.	Indicate CEM calibration/maintenance schedule:							
8.	Check which program(s) apply to the unit with the monitor:							
	□NSPS □SIP □PSD □BIF							
	□NESHAPS □Acid Rain □RCRA □Enhanced Monitoring							
9.	Monitor span: From: To:							
10.	Performance protocol (from Appendix B in 40 CFR Part 60):							
11.	Insitu/dilution extractive/extractive? (type):							
12.	If dilution extractive, give approximate dilution rate:							
	Conditioning system? ☐yes ☐no							
	If yes, what type?							
14.	Does Appendix F in 40 CFR Part 60 apply? ☐yes ☐no							
Naı	ne of person preparing application:							
Sig	nature: Date:							
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